·	Application No.	Applicant(s)	
Notice of Allowability	09/364,159 Examiner	SUZUKI ET AL.  Art Unit	
•	Andrew Schechter	2871	
The MAILING DATE of this communication appeal All claims being allowable, PROSECUTION ON THE MERITS IS herewith (or previously mailed), a Notice of Allowance (PTOL-85) NOTICE OF ALLOWABILITY IS NOT A GRANT OF PATENT RIOF of the Office or upon petition by the applicant. See 37 CFR 1.313	ears on the cover sheet with the co (OR REMAINS) CLOSED in this ap or other appropriate communication IGHTS. This application is subject to	orrespondence addre plication. If not include n will be mailed in due	ed course. <b>THIS</b>
1. $\boxtimes$ This communication is responsive to <u>the filing of 3 Septem</u>	<u>ber 2004</u> .		
2. The allowed claim(s) is/are 2,3,6 and 12-15.			
3. $\boxtimes$ The drawings filed on <u>30 July 1999</u> are accepted by the Ex	aminer.		
<ul> <li>4.  Acknowledgment is made of a claim for foreign priority ur</li> <li>a)  All b)  Some* c)  None of the:</li> <li>1.  Certified copies of the priority documents have</li> <li>2.  Certified copies of the priority documents have</li> <li>3.  Copies of the certified copies of the priority documents have</li> <li>International Bureau (PCT Rule 17.2(a)).</li> <li>* Certified copies not received:</li> </ul>	been received. been received in Application No		tion from the
Applicant has THREE MONTHS FROM THE "MAILING DATE" noted below. Failure to timely comply will result in ABANDONN THIS THREE-MONTH PERIOD IS NOT EXTENDABLE.		complying with the rec	quirements
5. A SUBSTITUTE OATH OR DECLARATION must be subm INFORMAL PATENT APPLICATION (PTO-152) which give	itted. Note the attached EXAMINER es reason(s) why the oath or declara	'S AMENDMENT or Nation is deficient.	OTICE OF
6. CORRECTED DRAWINGS (as "replacement sheets") mus	st be submitted.		
(a) ☐ including changes required by the Notice of Draftspers	on's Patent Drawing Review ( PTO-	·948) attached	
1)  hereto or 2)  to Paper No./Mail Date	•		
(b) ☐ including changes required by the attached Examiner's Paper No./Mail Date	s Amendment / Comment or in the C	Office action of	
Identifying indicia such as the application number (see 37 CFR 1 each sheet. Replacement sheet(s) should be labeled as such in t	.84(c)) should be written on the drawing the header according to 37 CFR 1.121(	ngs in the front (not the d).	back) of
7. DEPOSIT OF and/or INFORMATION about the depo attached Examiner's comment regarding REQUIREMENT	sit of BIOLOGICAL MATERIAL r FOR THE DEPOSIT OF BIOLOGIC	nust be submitted. N AL MATERIAL.	Note the
Attachment(s)  1. ☐ Notice of References Cited (PTO-892)  2. ☐ Notice of Draftperson's Patent Drawing Review (PTO-948)  3. ☐ Information Disclosure Statements (PTO-1449 or PTO/SB/0 Paper No./Mail Date  4. ☐ Examiner's Comment Regarding Requirement for Deposit of Biological Material	5. Notice of Informal F 6. Interview Summary Paper No./Mail Da 7. Examiner's Amendr 8. Examiner's Stateme 9. Other	(PTO-413), te ment/Comment	ŕ

Application/Control Number: 09/364,159

Art Unit: 2871

## **DETAILED ACTION**

## Allowable Subject Matter

- 1. Claims 2, 3, 6, and 12-15 are allowed.
- 2. The following is an examiner's statement of reasons for allowance:

The prior art does not disclose the device of claims 2, in particular the limitations that the display and back-surface electrodes are patterned in the same shape, that the back-surface electrode is connected to the TFT's active layer via a contact hole, and has a thickness greater than 200 Angstroms and less than or equal to 1500 Angstroms, and that the back-surface electrode is a high melting point metal. Claim 2 is therefore allowed, as are dependent claims 3, 6, and 15.

The prior art does not disclose the device of claim 12, in particular the limitations that the display and back-surface electrodes are patterned in the same shape, that the back-surface electrode is connected to the TFT's active layer via a contact hole and has a thickness greater than 200 Angstroms and less than or equal to 1500 Angstroms, and that the contact hole is formed between the one end portion of the back-surface electrode and the part of the active layer. (For instance, *Shintani* discloses that the contact hole is formed between the back-surface electrode and an intermediate layer [9a], rather than between the back-surface electrode and a part of the active element itself.) Claim 12 is therefore allowed.

The prior art does not disclose the reflective LCD of claim 13, in particular the limitations of surface electrode and back-surface electrode in the same shape, back-

Application/Control Number: 09/364,159

Art Unit: 2871

surface electrode on a smoothened film with a contact hole, and the back-surface electrode made of a high melting point metal and having a thickness greater than 200 Angstroms and less than or equal to 1500 Angstroms. Claim 13 is therefore allowed.

The prior art does not disclose the device of claim 14, in particular the limitations that the display and back-surface electrodes are patterned in the same shape, that the back-surface electrode is connected to the TFT's active layer via a contact hole, and has a thickness greater than 200 Angstroms and less than or equal to 1500 Angstroms, and that the back-surface electrode is made of a non-oxide metal. Claim 14 is therefore allowed.

Any comments considered necessary by applicant must be submitted no later than the payment of the issue fee and, to avoid processing delays, should preferably accompany the issue fee. Such submissions should be clearly labeled "Comments on Statement of Reasons for Allowance."

## Conclusion

Any inquiry concerning this communication or earlier communications from the examiner should be directed to Andrew Schechter whose telephone number is (571) 272-2302. The examiner can normally be reached on Monday - Friday, 9:00 - 5:30.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Robert H. Kim can be reached on (571) 272-2293. The fax phone number for the organization where this application or proceeding is assigned is 703-872-9306.

Application/Control Number: 09/364,159

Art Unit: 2871

Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free).

> Andrew Scheetter **Andrew Schechter Patent Examiner**

**Technology Center 2800** 

Page 4

21 October 2004